



PATENT

UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: TEUSCHLER ET AL 1
SERIAL NO: 10/762,111 GROUP: 2811
FILED: January 21, 2004
TITLE: POLISHED SEMICONDUCTOR WAFER AND PROCESS FOR
PRODUCING IT

SUBMISSION OF INFORMATION DISCLOSURE STATEMENT
OF DR. WOLFGANG STAUDACHER

Mail Stop: MISSING PARTS
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants wish to bring to the attention of the Patent Examiner the attached Information Disclosure Statement, duly signed by Dr. Wolfgang Staudacher, and the references listed on the enclosed Form PTO-1449 and attached thereto. The enclosed references are believed to be material to the examination of the above-identified application.

Since this Information Disclosure Statement is being filed prior to a first Office Action, it is believed that no fee is due. However, if it is determined that a fee is due, the Commissioner is hereby authorized to charge, or to credit any over payment, to our Deposit Account Number 03-2468.

It is respectfully requested that this Information Disclosure Statement be considered and placed into the application file.

Respectfully submitted,
Thomas TEUSCHLER ET AL 1

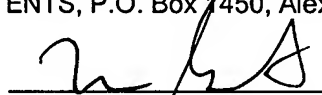


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Enclosures: 1) IDS of Dr. Wolfgang Staudacher
 2) PTO form 1449
 3) 9 references

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: COMMISSIONER OF PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450 on June 30, 2004.


Maria Guastella



In re application of:
TEUSCHLER ET AL 1

Serial Number :

Group Art Unit:

Filed:

For: POLISHED SEMICONDUCTOR WAFER AND PROCESS FOR PRODUCING IT

Information Disclosure Statement

Honorable Commissioner of Patents and Trademarks
Washington, D.C. 20231

Sir or Madam:

I, Wolfgang Staudacher, associated with the preparation and prosecution of the above-identified application, residing at Seebauerstraße 4, 81735 München, Germany, wish to call the attention of the Patent Examiner to the references enumerated on the enclosed PTO Form-1449.

I believe the documents enumerated on the enclosed Form PTO-1449 and attached thereto, are cited in the application and/or the Office Action of the German Patent and Trademark Office and may be material to the examination of the application.

Therefore, it is respectfully requested that the foregoing Information Disclosure Statement be considered by the Examiner and incorporated into the file of this application.

I wish to comment as follows concerning the prior art references enumerated on PTO Form-1449:

For EP 1 119 031 A2, cited in the application an English Derwent Abstract is enclosed.

US 5, 451,267, cited in the application, is already in English language.

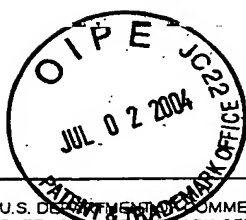
DE 100 02 354, cited in the German Office Action, corresponds to EP 1 119 031 A2.

US 5,474,644, cited in the German Office Action, is already in English language.

For DE 100 64 081 C2 and DE 102 15 960 A1, both cited in the German Office Action, an English Derwent Abstract is enclosed respectively.

Signed this 2nd day of March, 2004.


Dr. Wolfgang Staudacher

FORM PTO-1449
(REV. 7-80)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO. : ST 10302

SERIAL NO. 10/762,111

LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

APPLICANT : TEUSCHLER ET AL. 1

FILING DATE: JAN. 21, 2004

GROUP: 2811

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	5,451,267	9/19/95	Stadler et al.			
	AB	5,474,644	12/12/95	Kato et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AL	EP 111 903 A	7/25/01	Europe				
	AM	DE 100 023 54	8/9/01	Germany				
	AN	DE 100 640 81	6/6/02	Germany				
	AO	DE 102 159 60	10/17/02	Germany				
	AP							

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR	English Derwent Abstract corresponding to EP 111 903 A (AN 2002 - 207 693)
	AS	English Derwent Abstract AN 2002 - 228 281 corresponding to DE 100 640 81
	AT	English Derwent Abstract corresponding to DE 102 159 60 (AN 2003 - 020 868)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.